

	Type	Hits	Search Text	DBs
9	BRS	353	(grinding same polishing same support\$3 same substrate)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB
21	BRS	7943	(resistivity same silicon same substrate)	USPAT; EPO; JPO
22	BRS	172	S21 and piezoelectric	USPAT; EPO; JPO